

Inventor(s): Ming Li et al.
Title: ULTRAFAST LASER DIRECT WRITING
METHOD FOR MODIFYING EXISTING
MICROSTRUCTURES ON A SUBMICRON
SCALE
Attorney Docket No.: MATG-401US

Figure 3B

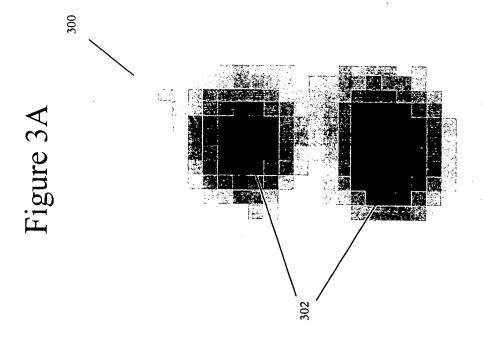
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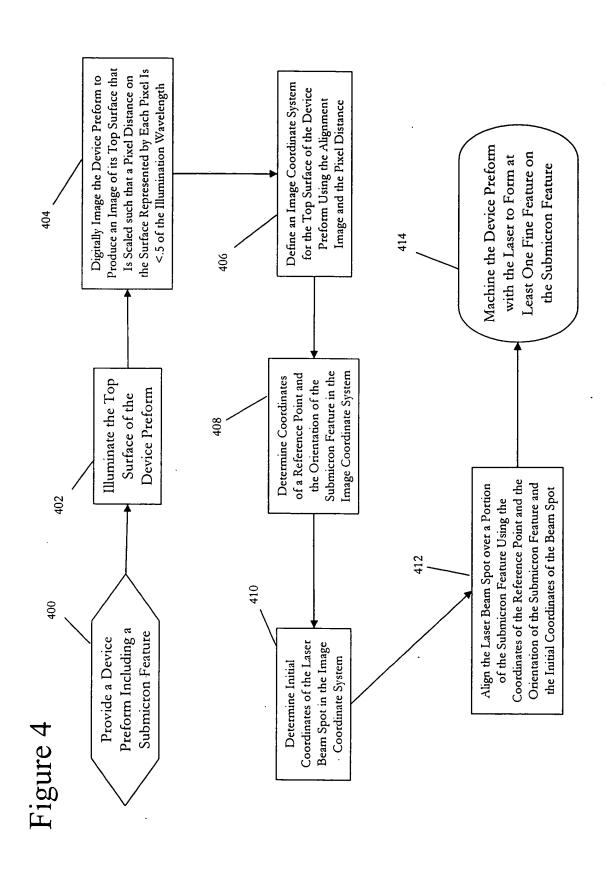
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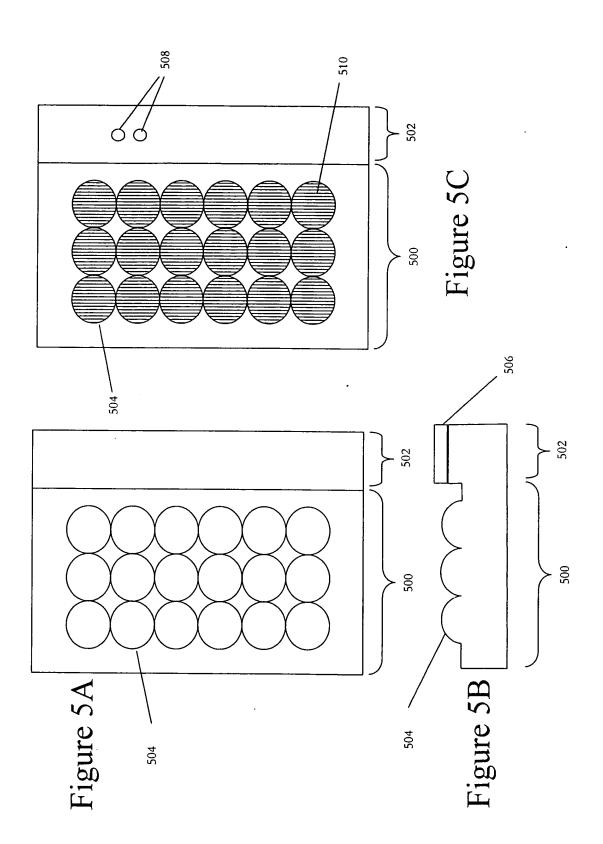
302

10 Pixels

10 Pixels







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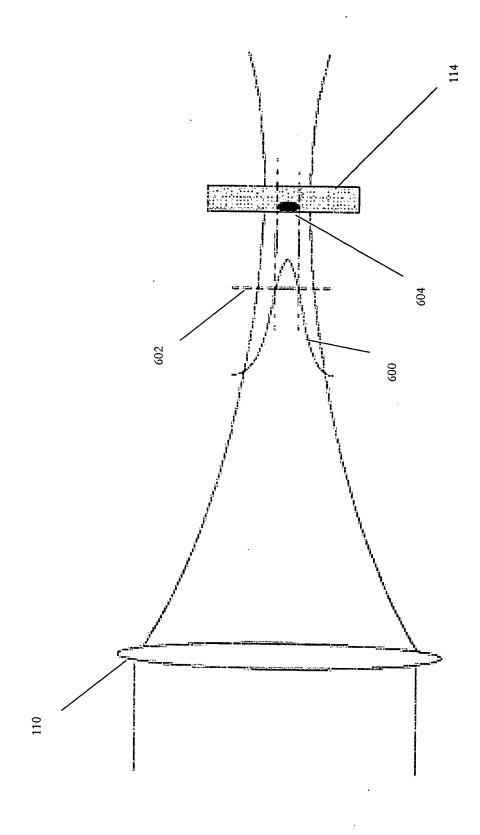


Figure 6

